

Title (en)

METHOD AND DEVICE FOR MAINTAINING A CLEAN ATMOSPHERE AT CONTROLLED TEMPERATURE AT A WORKSTATION.

Title (de)

VERFAHREN UND VORRICHTUNG ZUM AUFRECHTERHALTEN EINER REINEN UND TEMPERIERTEN ATMOSPHÄRE AN EINEM ARBEITSPLATZ.

Title (fr)

PROCEDE ET DISPOSITIF POUR MAINTENIR UNE ATMOSPHERE PROPRE A TEMPERATURE REGULEE SUR UN POSTE DE TRAVAIL.

Publication

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Application

**EP 90914739 A 19901001**

Priority

- FR 9000700 W 19901001
- FR 8912861 A 19891002

Abstract (en)

[origin: US5312294A] PCT No. PCT/FR90/00700 Sec. 371 Date Mar. 30, 1992 Sec. 102(e) Date Mar. 30, 1992 PCT Filed Oct. 1, 1990 PCT Pub. No. WO91/05210 PCT Pub. Date Apr. 18, 1991.A method and device for maintaining a clean atmosphere at controlled temperature, at a workstation accessible from a contaminated room. A curtain of gas-in the form of a slow jet and of a fast jet-is generated at the level of the openings between the workstation and the contaminated zone. The fast jet is situated at the level of the opening on the workstation side; the jets are directed approximately in parallel to the opening so that at least the external face of the fast jet reaches up to the opening. Moreover, a stream of clean gas is generated, and sent in such a way as to create a uniform sweeping, inside the volume to be protected.

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**F24F 9/00; F24F 3/16**

IPC 8 full level

**F24F 3/16** (2006.01); **F24F 9/00** (2006.01)

CPC (source: EP US)

**F24F 3/163** (2021.01 - EP US); **F24F 9/00** (2013.01 - EP US); **F24F 2009/007** (2013.01 - EP US)

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**WO 9105210 A1 19910418**; AT E118268 T1 19950215; DE 69016793 D1 19950323; DE 69016793 T2 19950622; DK 0494921 T3 19950410; EP 0494921 A1 19920722; EP 0494921 B1 19950208; ES 2071116 T3 19950616; FR 2652520 A1 19910405; FR 2652520 B1 19920207; JP H05500849 A 19930218; JP H0833223 B2 19960329; US 5312294 A 19940517

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